

Title: METHOD OF FABRICATING X-RAY MASK AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE
WITH X-RAY MASK FABRICATED BY THIS METHOD

Inventors: WATANABE et al.

Atty Docket No.: 402721

Leydig, Voit & Mayer 202-737-6770

FIG.1

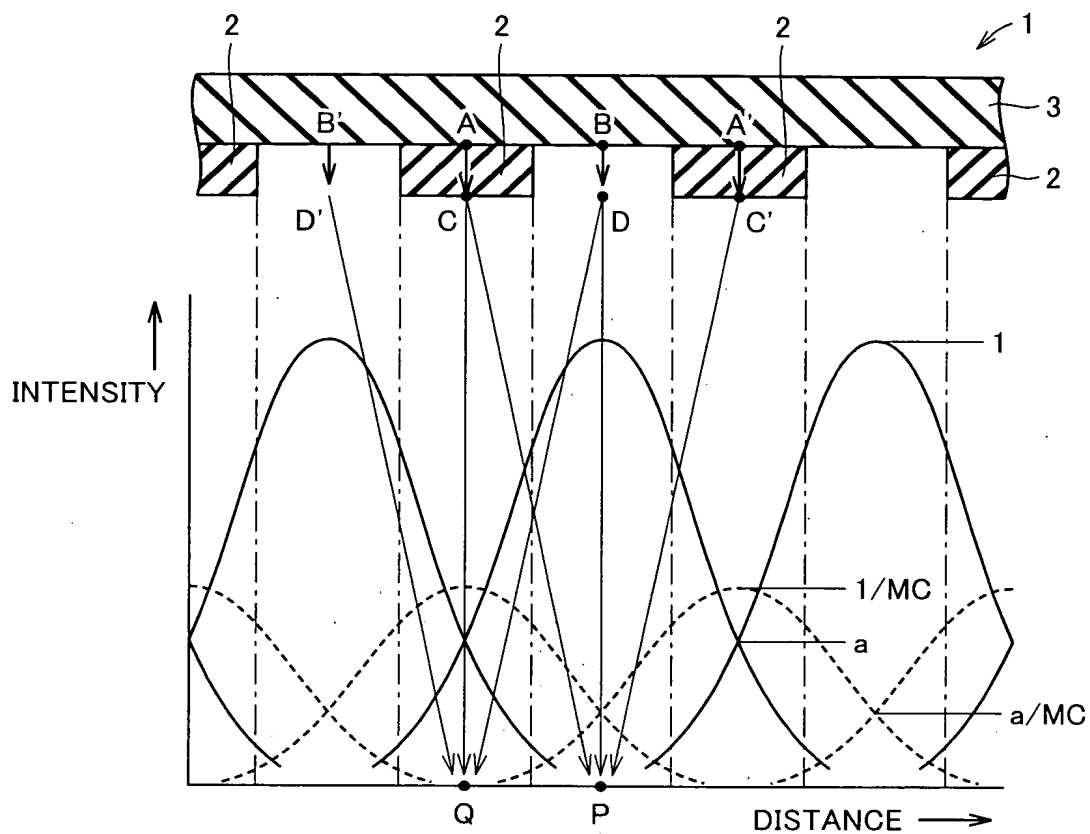


FIG.2

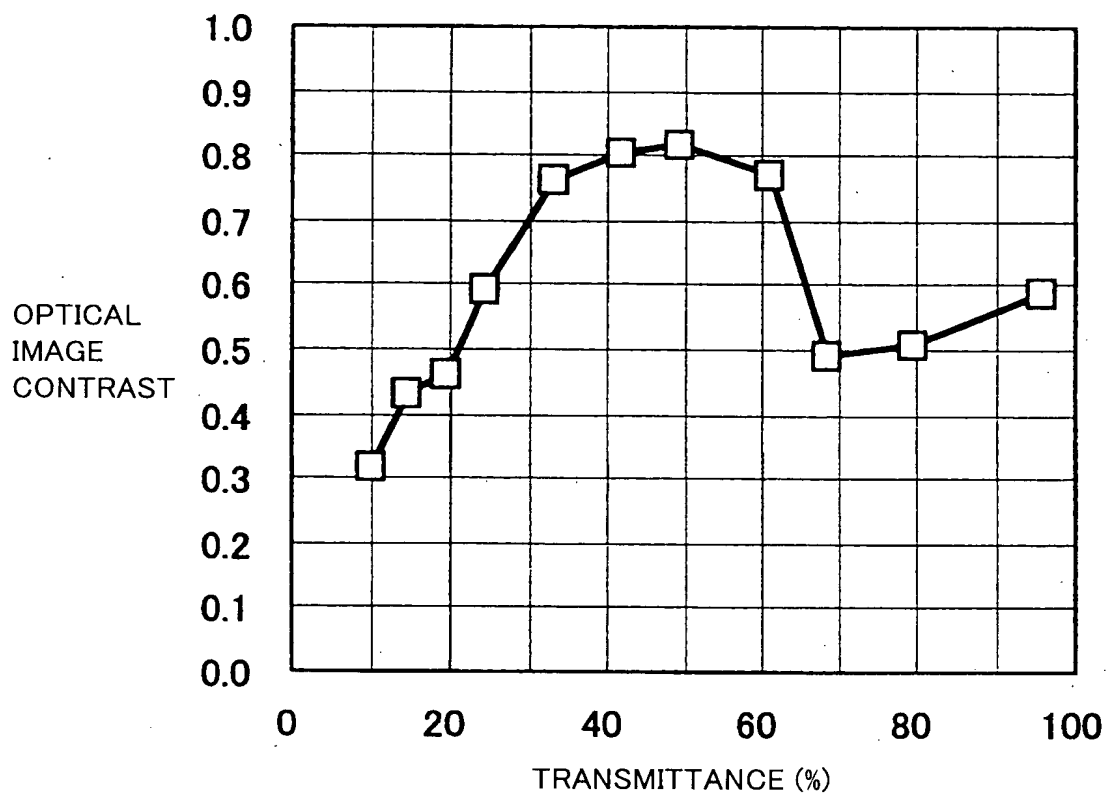
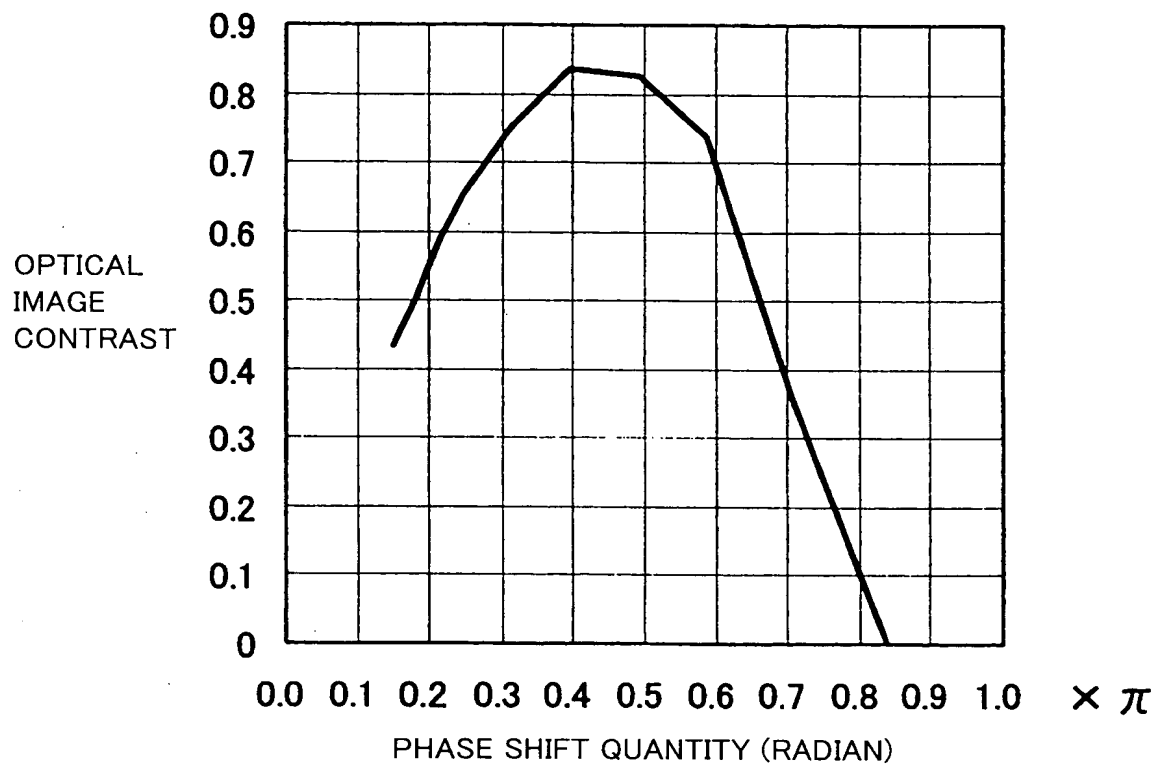


FIG.3



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FIG.4

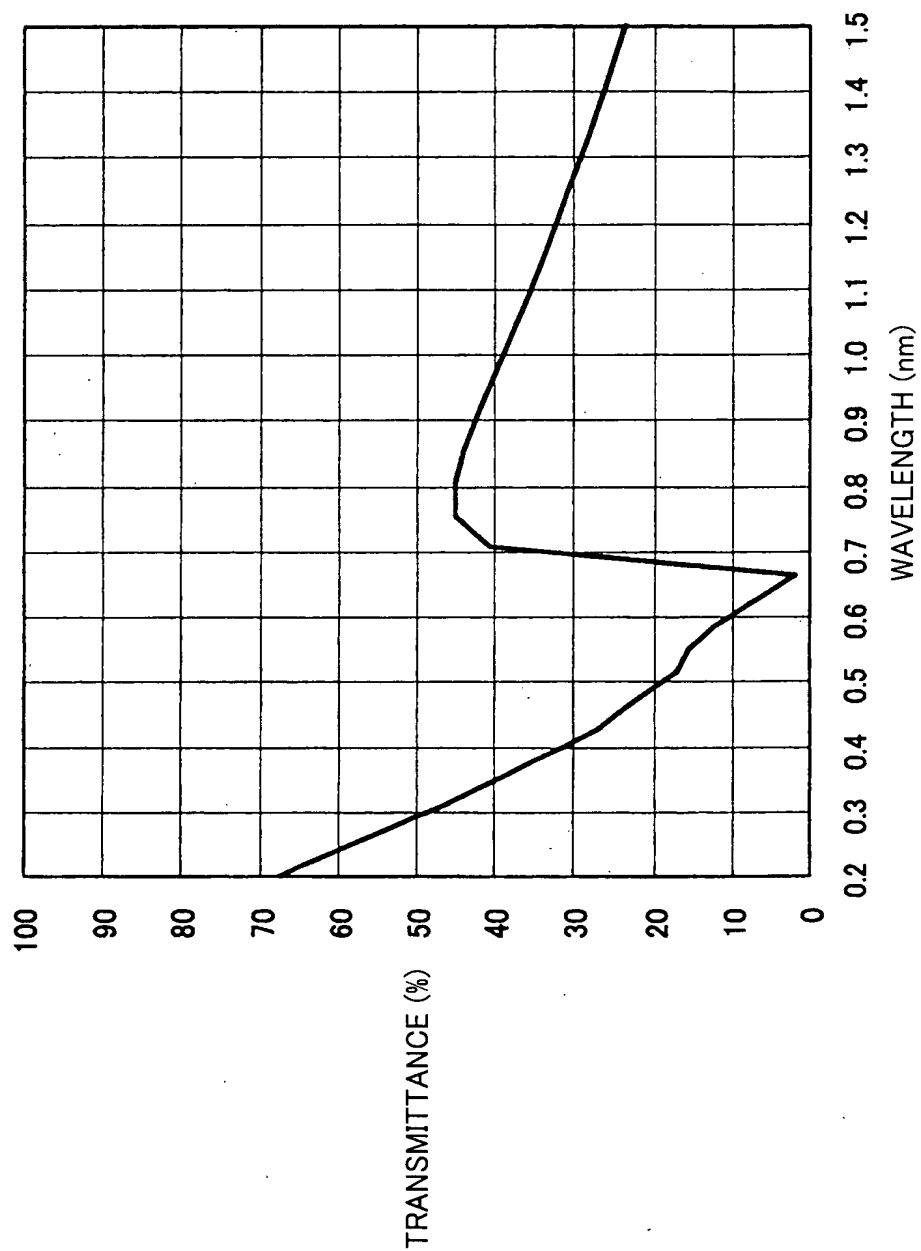


FIG.5

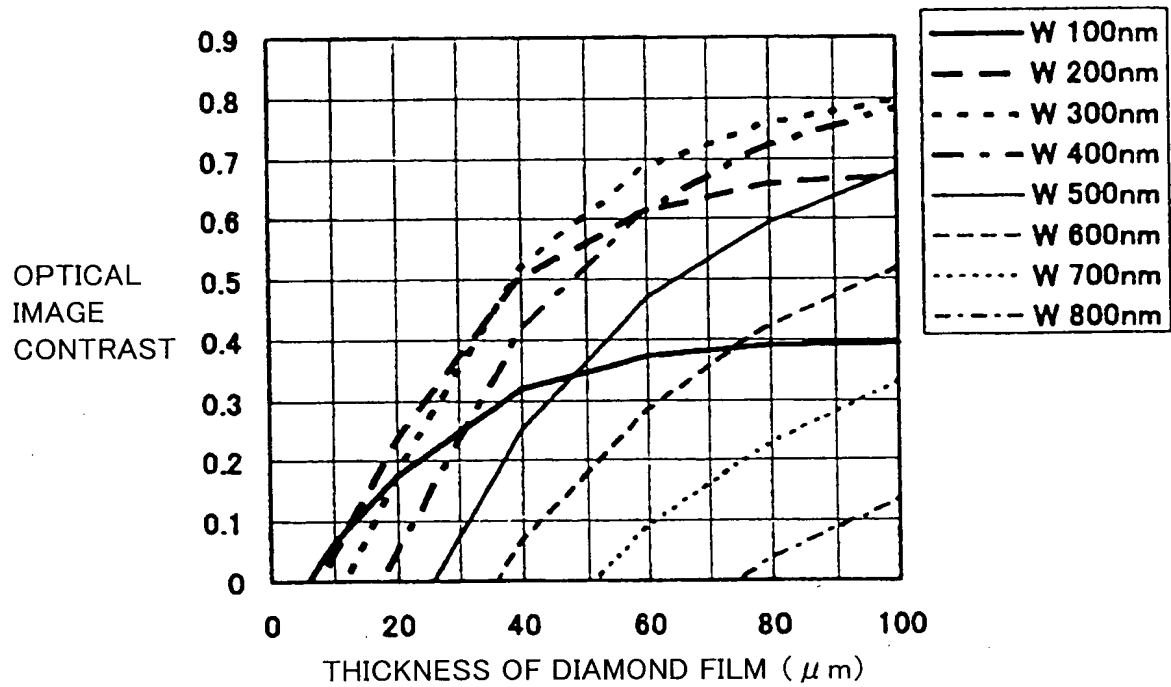


FIG.6

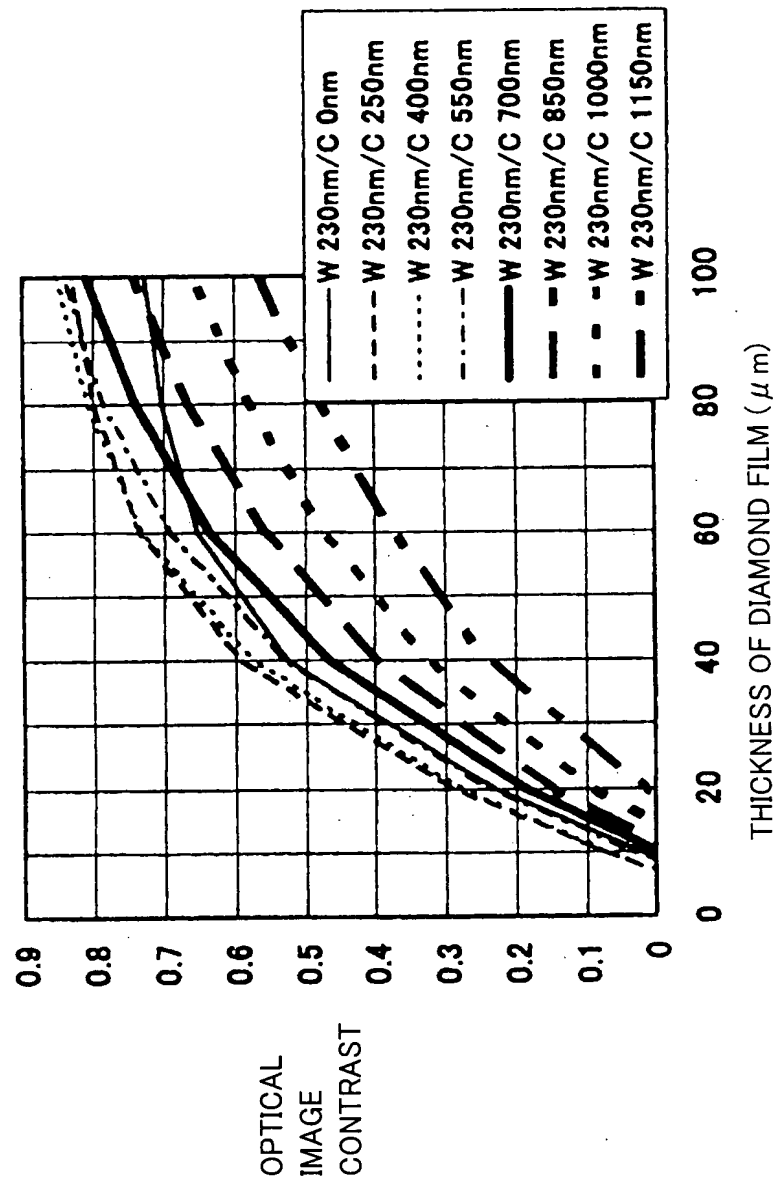


FIG.7

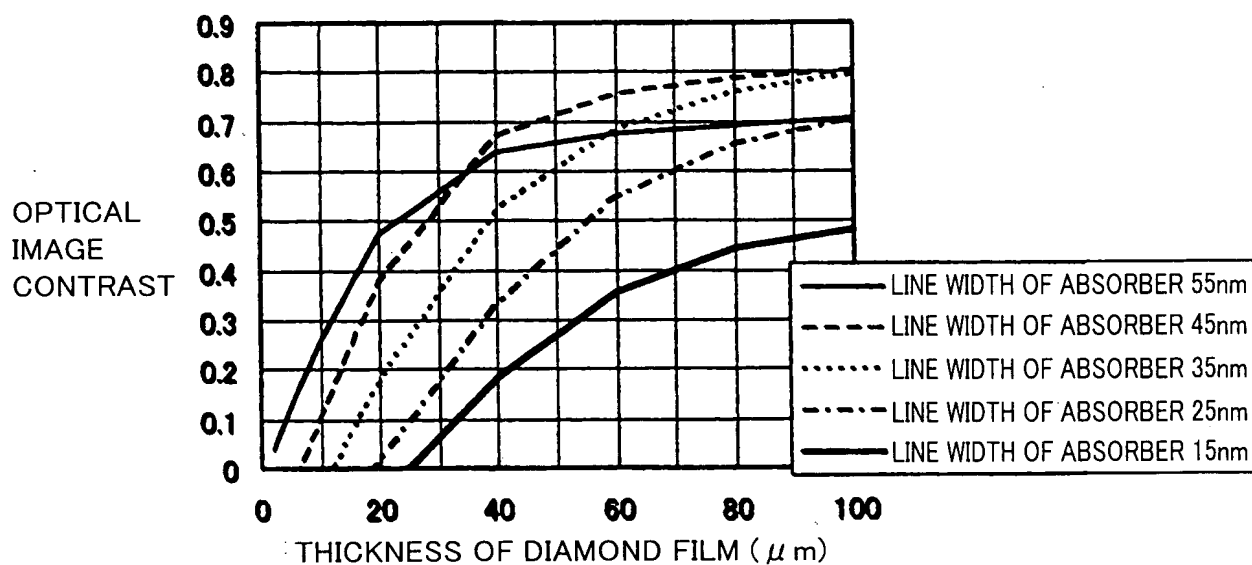
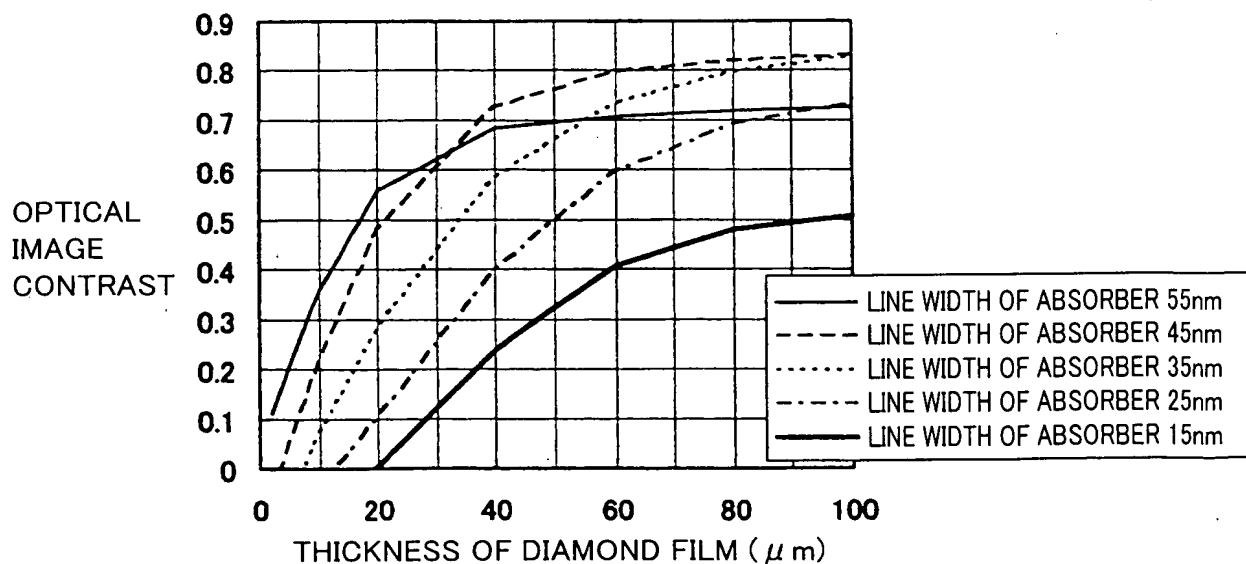


FIG.8



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FIG.9

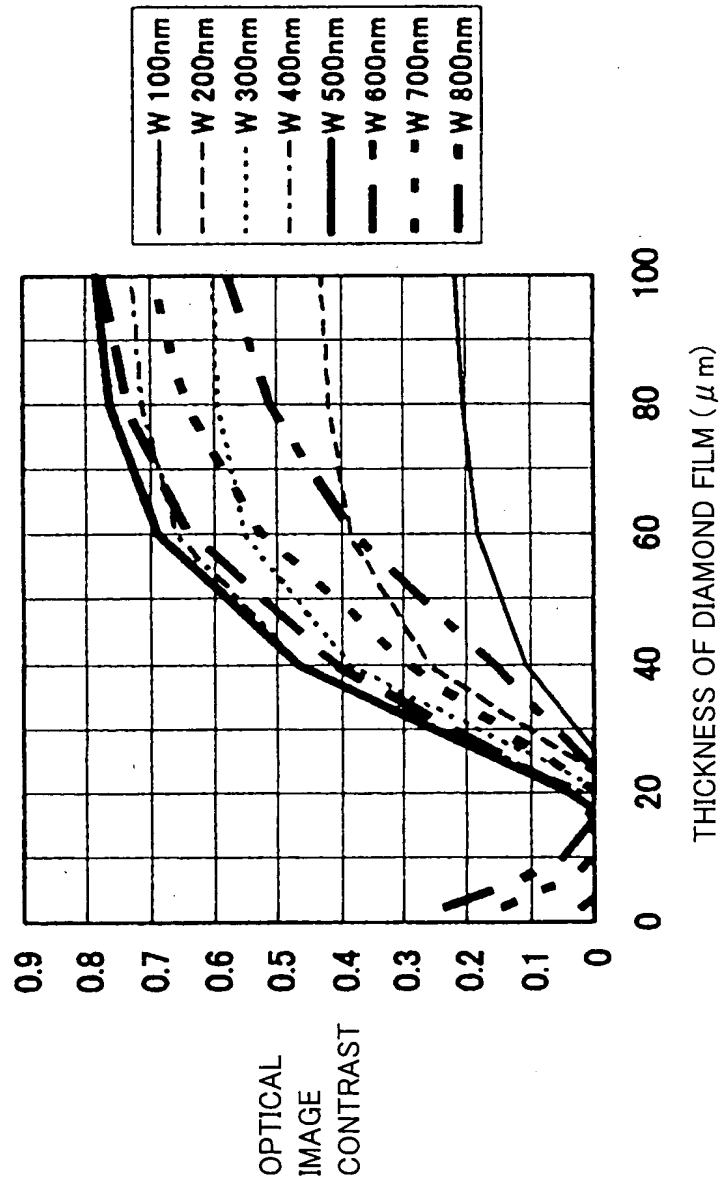


FIG.10

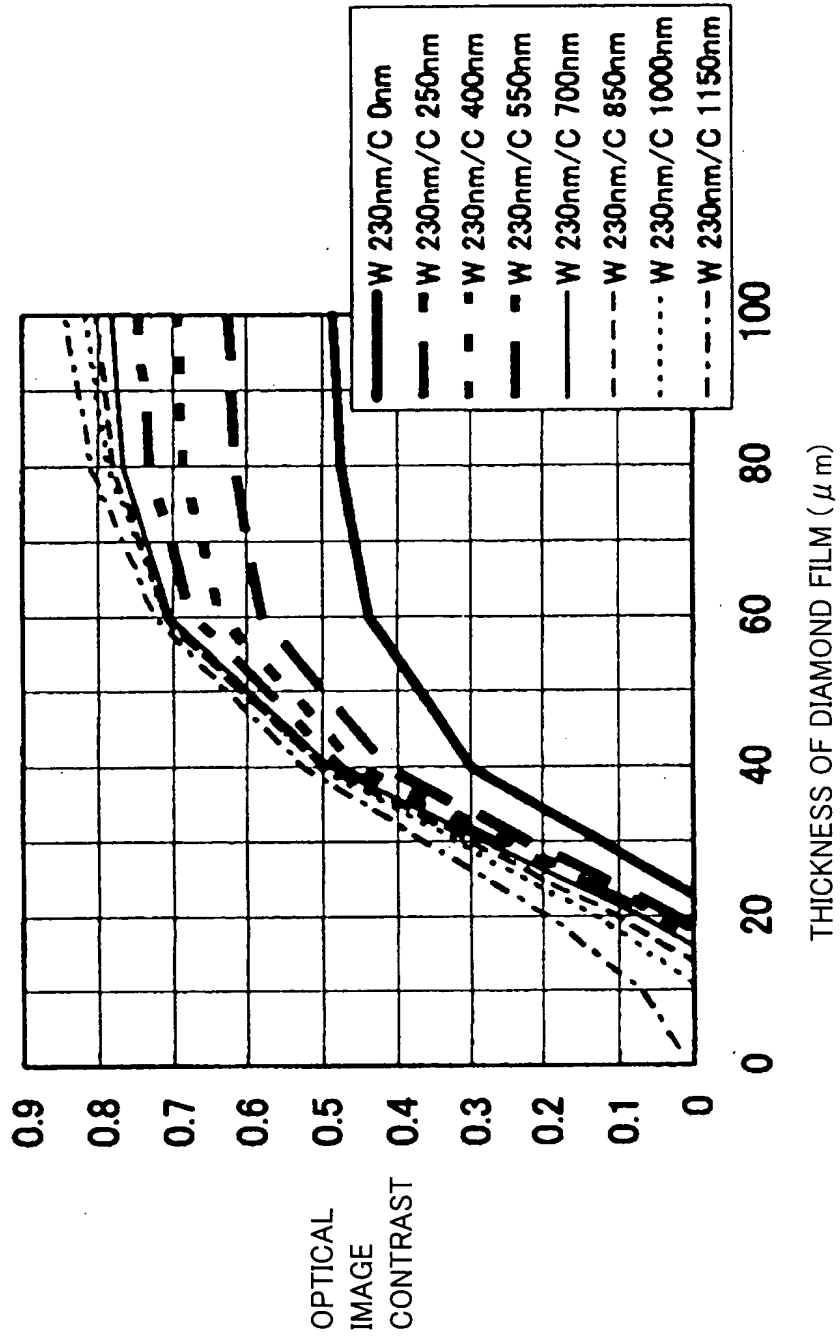


FIG.11

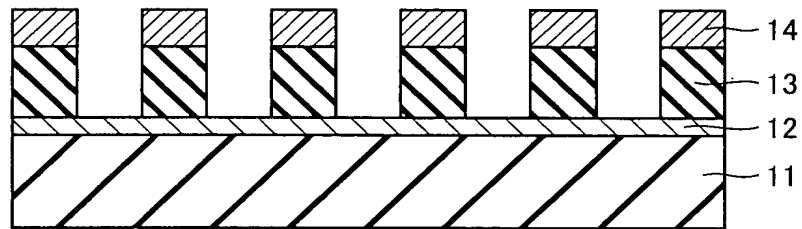


FIG.12

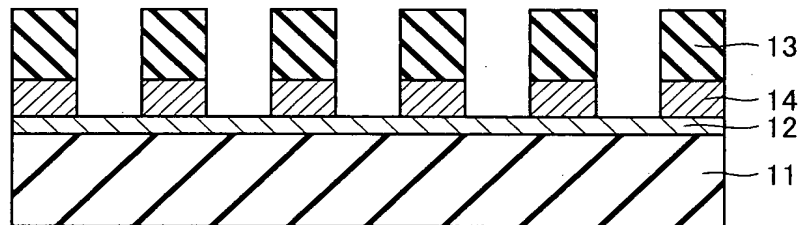


FIG.13

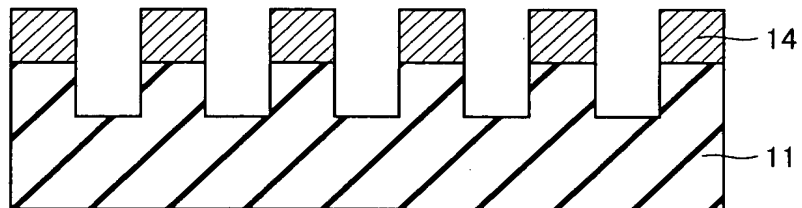


FIG.14

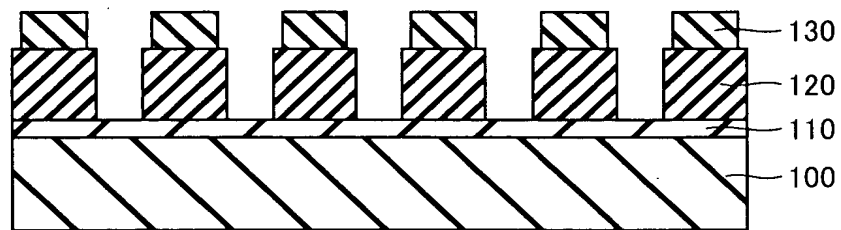


FIG.15

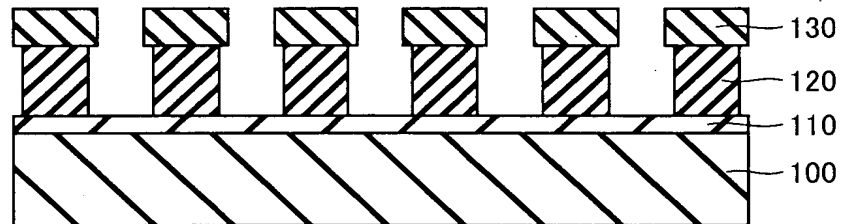


FIG.16

